

#4
C. Burk

FORM PTO-1449 (Modified)								ATTY. DOCKET NO. HUBR 1165		SERIAL NO. 09/647,207	
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)								APPLICANTS Stuke, et al.			
								FILING DATE 01-08-2001	GROUP 1733		
REFERENCE DESIGNATION				U.S. PATENT DOCUMENTS							
EXAMINER INITIAL				DOCUMENT NUMBER		DATE		NAME		SUB-CLASS	FILING DATE IF APPROPRIATE
<i>JTG</i>	AA	3	9	9	7	3	8	6	12/14/76	<i>034100</i> Hiroaki et al.	
	AB	5	5	8	9	8	6	0	12/31/96	<i>SUGAWA</i> Takeshi et al.	
	AC	4	3	1	5	0	5	0	2/9/82	Rourke	
	AD	5	5	0	0	4	5	9	3/19/96	<i>AKIGEMEYER</i> Beauvois et al.	
	AE	5	1	5	6	7	1	0	10/20/92	<i>CHE</i> Schadt et al.	
	AF	5	8	8	2	4	6	5	3/16/99	McReynolds	
FOREIGN PATENT DOCUMENTS											
EXAMINER INITIAL				DOCUMENT NUMBER		DATE		COUNTRY		SUB-CLASS	TRANSLATION YES NO
<i>JTG</i>	AG	9	0	1	4	9	4	0	12/13/90	WO	/ /
	AH	9	4	2	9	4	0	0	12/22/94	WO	/ /
	AI	7	7	0	8	7	1		5/2/97	EP	/ /
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)											
<i>JTG</i>		Roberts et al. "UV Laser Machined ...Systems", Analytical Chemistry, Vol. 69. No. 11, 6/1/97 - pages 2035-2042.									
		Patent Abstracts of Japan, Vol. 016. - 2/21/92 and JP 03 262645 A (Seiko), 11/22/91									
		Patent Abstracts of Japan, Vol. 017 - 4/16/93 and JP 04 341833 (Ishikawajima), 11/27/92									
		Patent Abstracts of Japan, Vol. 095 - 7/31/95 and JP 07 070335 (Mitsui), 3/14/95									
		Patent Abstracts of Japan, Vol. 098 - 4/30/98 and JP 10 016244A (Canon), 1/20/98									
<i>JTG</i>	<i>GREGORY GATEL</i>	DATE CONSIDERED 10 JUNE 2001									

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw Line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

(INFORMATION DISCLOSURE STATEMENT - SECTION 9 PTO-1449 [6-1] page 1 of 2)

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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>JTG</i>		Patent Abstracts of Japan, Vol. 096, 9/30/96 & JP 08 118661 A (Fuji), 5/14/96					
EXAMINER	<i>GARRETT</i>			DATE CONSIDERED 10 JUNE 2002			

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(INFORMATION DISCLOSURE STATEMENT - SECTION 9 PTO-1449 [6-1] page 2 of 2)